

<b>Notice of References Cited</b>	Application/Control No. 10/666,090	Applicant(s)/Patent Under Reexamination LAM ET AL.	
	Examiner Peter Y. Choi	Art Unit 1771	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,875,711	04-2005	Chen et al.	442/72
	B	US-			
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	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	EP 1203897 A1	05-2002	European Patent	LAM et al.	
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*Pat L*  
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